



PATENT  
8017-1122

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Noriaki ODA

Conf. 2345

Application No. 10/761,204

Group 2826

Filed January 22, 2004

Examiner Alexander Williams

SEMICONDUCTOR DEVICE AND METHOD OF  
FABRICATION SAME

AMENDMENT

MS AMENDMENT

Commissioner for Patents

August 30, 2005

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Responsive to the Official Action of June 30, 2005, for which the period for response has been extended one month, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.